



PATENT  
Docket No.: ACT-307DVA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2814

Examiner: Mai, Anh D.

Serial No.: 10/036,303

Filed: December 28, 2001

In re Application of: Hawley et al.

For: METHOD FOR FABRICATING A MOS TRANSISTOR HAVING IMPROVED  
TOTAL RADIATION-INDUCED LEAKAGE CURRENT

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail, in an envelope addressed Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 11/3/03.

Signed Krista Thompson  
Krista Thompson

**REQUEST FOR EXTENSION OF TIME**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicant(s) request an extension of time of One month to respond to the Office Action dated July 1, 2003. Enclosed is the requisite fee of \$110.00 as calculated pursuant to 37 C.F.R. §1.17(a-c) below:

	Small Entity	Std. Fee
One month extension	<input type="checkbox"/> \$ 55.00	<input checked="" type="checkbox"/> \$ 110.00
Two month extension	<input type="checkbox"/> \$205.00	<input type="checkbox"/> \$ 410.00
Three month extension	<input type="checkbox"/> \$465.00	<input type="checkbox"/> \$ 930.00

The Assistant Commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account No.: 50-0612.

Dated: November 3, 2003

Respectfully submitted,  
SIERRA PATENT GROUP, LTD.

Sierra Patent Group, Ltd.  
P.O. Box 6149  
Stateline, NV 89449  
(775) 586-9500  
(775) 586-9550

Andrew D. Gathy  
Reg. No. 46,441

RECEIVED  
NOV 12 2003  
TECHNOLOGY CENTER 2800

11/07/2003 AOSMAN1 00000025 10036303

01 FC:1251

110.00 OP